



Patitioner's Docket No.: 811_001

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of: Yuji KATSUDA, Jun YOSHIKAWA, Masaaki MASUDA and Chikashi IHARA

Ser. No.: 09/982,484

Group Art Unit: 1775

Filed: October 18, 2001

Examiner: Stein, S.

Confirmation No.: 7015

For: A MATERIAL OF LOW VOLUME RESISTIVITY, AN ALUMINUM NITRIDE SINTERED BODY AND A MEMBER USED FOR THE PRODUCTION OF SEMICONDUCTORS

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Assistant Commissioner for Patents
Washington, DC 20231

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Tara L. Preston
Tara L. Preston

AMENDMENT

Sir:

In response to the Office Action mailed October 9, 2002, please amend the above-identified application as follows:

In the Specification:

Attached hereto as pages 31-43, pursuant to Rule 1.121(b)(1)(ii) is a clean version of specification paragraphs incorporating changes being made thereto and containing instructions for replacing paragraphs in the specification. Attached hereto as pages 44-55, pursuant to Rule 1.121(b)(1)(iii) is a marked-up version of the specification paragraphs showing the changes being made thereto.

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